



IFW AF/2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **WATANABE, Takayuki et al.**

Group Art Unit: **2822**

Serial No.: **10/073,877**

Examiner: **M. F. GUERRERO**

Filed: **February 14, 2002**

P.T.O. Confirmation No.: 6745

For: **PROCESS OF MANUFACTURING A SEMICONDUCTOR DEVICE**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 2822

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 8, 2004

Sir:

In response to the Office Action dated **June 8, 2004**, please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.